



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroto HORIKAWA

Group Art Unit: 2851

Application No.: 09/139,296

Examiner: P. Kim

Filed: August 25, 1998

Docket No.: 101809.01

For: STAGE UNIT, DRIVE TABLE, AND SCANNING EXPOSURE APPARATUS USING
SAME

AMENDMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In reply to the September 16, 2002 Office Action, the shortened statutory period for
reply being extended by the attached Petition for Extension of Time, please amend the above-
identified application as follows:

IN THE CLAIMS:

Please replace claims 29 and 31 as follows:

29. (Amended) A lithographic device comprising the following elements which
are supported in that order:

a substrate stage which can be positioned by a first positioning device parallel
to a Y-direction which is perpendicular to a vertical Z-direction and an X-direction which is
perpendicular to the Y-direction and to the Z-direction;

an imaging system with a main axis directed parallel to the Z-direction;

a mask stage which can be positioned parallel to the Y-direction by a second
positioning device; and

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